

Refine Search

Search Results -

Terms	Documents
semiconductor and (nanoscale same roughness).clms.	0

Database:

US Pre-Grant Publication Full-Text Database

 US Patents Full-Text Database
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 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L7

Search History

 DATE: Monday, October 03, 2005 [Printable Copy](#) [Create Case](#)
Set Name Query

side by side

Hit Count Set Name

result set

DB=PGPB; PLUR=YES; OP=ADJ
L7 semiconductor and (nanoscale same roughness).clms.

 0 L7
DB=JPAB; PLUR=YES; OP=ADJ
L6 semiconductor and (nanoscale same roughness)

 0 L6
DB=EPAB; PLUR=YES; OP=ADJ
L5 semiconductor and (nanoscale same roughness)

 0 L5
DB=USPT; PLUR=YES; OP=ADJ
L4 semiconductor and (nanoscale same roughness)

 27 L4
DB=PGPB; PLUR=YES; OP=ADJ
L3 semiconductor and (nanoscale same roughness)

 40 L3
DB=TDBD; PLUR=YES; OP=ADJ
L2 semiconductor and (nanoscale same roughness)

 1 L2
DB=DWPI; PLUR=YES; OP=ADJ
L1 semiconductor and (nanoscale same roughness)

 1 L1

END OF SEARCH HISTORY